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Docket No. 15-XZ-5547

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PATENT APPLICATION OF:

Nicolas, et al.

SERIAL NO.: 10/003,490

FILED: November 1, 2001

FOR: Low-Dose Exposure Aided Positioning
(LEAP) for Digital Radiography

EXPRESS MAIL NO. EL849010291US

Date: May 8, 2002

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
Washington, D.C. 20231

Dear Sirs:

Pursuant to 37 C.F.R. § 1.56, it is respectfully requested that the following reference(s) be considered in the examination of the above-identified patent application:

5,218,625 June 8, 1993 Heidsieck

The above-identified reference is listed on the attached PTO Form 1449 and copies are also enclosed herewith.

This submission, is in no way intended as an admission that the above-cited reference constitute prior art under any subsection of 35 U.S.C. § 102. Applicant expressly retains the right to take any actions necessary to remove the above-cited reference from the available prior art.

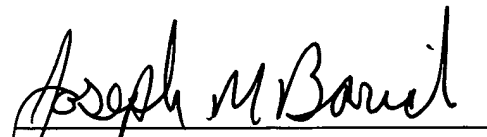
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Consideration of the above-identified references in the examination of the present patent application is respectfully requested.

No fee is believed to be due because it is believed that this statement and enclosures are being filed before the first Office Action on the merits has been mailed by the PTO. The basis of this belief is that no Office Action on the merits appears to have been received by the undersigned to date. Please charge any fees due in connection with this statement to the deposit account of McAndrews, Held & Malloy, Ltd., Account No. 13-0017.

Respectfully submitted,

Date: May 8, 2002



Joseph M. Barich
Reg. No. 42,291